

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Leonard Forbes

Title:

SILICON-GERMANIUM DEVICES FOR CMOS FORMED BY ION IMPLANTATION AND SOLID PHASE

EPITAXIAL REGROWTH

Docket No.:

303.229US2

Filed:

August 11, 1998

Examiner:

Unknown

Serial No.: 09/132,157 Due Date: N/A

Group Art Unit: 2812

Assistant Commissioner for Patents

Washington, D.C. 20231

We are transmitting herewith the following attached items (as indicated with an "X"):

<u>X</u> A return postcard.

A Preliminary Amendment (3 Pages). <u>X</u>

A check in the amount of \$246.00 to cover the fee for additional claims as calculated below 1 1 1998

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GROUP 2100

If an additional fee is required due to changes to the claims, the fee has been calculated as follows:

CLAIMS AS AMENDED						
	(1) Claims Remaining After Amendment		(2) Highest Number Previously Paid For	(3) Present Extra	Rate	Fee
TOTAL CLAIMS	18	-	20		x 22 =	\$0.00
INDEPENDENT CLAIMS	6	-	3	3	x 82 =	\$246.00
[] MULTIPLE DEPENDENT CLAIMS PRESENTED						\$0.00
TOTAL						\$246.00

Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional required fees or credit overpayment to Deposit Account No. 19-0743.

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this Transmittal Letter and the paper, as described above, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this _______ day of September, 1998.

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(GENERAL)

S/N 09/132,157

PATENT

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IMPLANTATION AND SOLID PHASE EPITAXIAL REGROWTH

SECOND PRELIMINARY AMENDMENT

B

ssistant Commissioner for Patents

Washington, D.C. 20231

When the above-identified patent application is taken up for consideration, please amend the application as follows:

IN THE CLAIMS

Please add claims 24-37 for consideration in the initial examination. Claims 11-14 remain pending as well.

OCT 1 / 1000

Sul. Ca 24. (New) A semiconductor transistor formed on a silicon substrate, comprising:

a Si_{1-x}Ge_x channel region, having a germanium molar fraction of x, and formed in the substrate, underneath a gate oxide and between a source region and a drain region.

- BI
- 25. (New) The transistor of claim 24, wherein the Si_{1-x}Ge_x channel region is formed from ion implanting germanium (Ge) into the substrate at a dose of approximately 2 X 10¹⁶ atoms/cm², and wherein the Ge is implanted at an energy of approximately 20 to 100 keV.
- 26. (New) The transistor of 24, wherein the Ge is dispersed in the substrate to a depth of approximately 100 to 1,000 angstroms.
- 27. (New) The transistor of 24, wherein the Ge is dispersed in the substrate to a depth of approximately 300 angstroms.